



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cyril Cabral Jr.

Group Art Unit: 2827

Serial No.: 09/686,742

Examiner: Lourdes Cruz

Filed: Oct. 11, 2000

In Response to Office Action
Dated: July 31, 2002

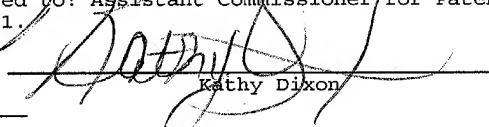
For: Semiconductor Structure Having In-Situ Formed
Unit Resistors and Method for Fabrication

Attorney Docket No.: 64,610-057 (YOR9-2000-0361US1)

2827
#3/A
Amend
Ltrb
drafB
RECEIVED
TECHNOLOGY CENTER 2800
NOV -7 2002
J. J. McNeely
11/10/02

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.


Kathy Dixon

Date: Oct. 31, 2002

RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
Washington, D.C. 20231

Dear Sir:

In response to an Office Action mailed July 31, 2002,
please enter the following amendments and consider the following
remarks.